

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10564475
	Filing Date		2006-07-25
	First Named Inventor	GRUDIN, Oleg	
	Art Unit	3729	
	Examiner Name	PHAN, Thiem D.	
	Attorney Docket Number	14836-14US AD/ad	

U.S.PATENTS							Remove
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear	
	1	3887863		1975-06-03	BROKAW		
	2	4250445		1981-02-10	BROKAW		
	3	6306718		2009-02-27	SINGH et al.		
	4	5252908		1993-10-12	BROKAW		
	5	4210996		1980-07-08	AMEMIYA et al.		
If you wish to add additional U.S. Patent citation information please click the Add button.							Add
U.S.PATENT APPLICATION PUBLICATIONS							Remove
Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publication Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear	
	1	20030006831		2003-01-09	COADY		
If you wish to add additional U.S. Published Application citation information please click the Add button.							Add
FOREIGN PATENT DOCUMENTS							Remove

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10564475
Filing Date	2006-07-25
First Named Inventor	GRUDIN, Oleg
Art Unit	3729
Examiner Name	PHAN, Thiem D.
Attorney Docket Number	14836-14US AD/ad

Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ² i	Kind Code ⁴	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear	T ⁵
	1	WO03023794			2003-03-20	LANDSBERGER et al.		<input type="checkbox"/>

If you wish to add additional Foreign Patent Document citation information please click the Add button

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T ⁵
	1	International Search Report dated January 31, 2005 from International Patent Application No. PCT/CA2004/001030	<input type="checkbox"/>
	2	Y. Amemiya, T. Ono, K. Kato: "Electrical Trimming of Heavily Doped Polycrystalline Silicon Resistors", IEEE Trans. Electron. Dev. vol. ED-26 (1979), 11, pp.1738-1742	<input type="checkbox"/>
	3	J. Babcock, P. Francis, R. Bashir, A. Kabir, D. Shroder, M. Lee, T. Dhayagude, W. Yindeepol, S. Prasad, A. Kalnitskiy, M. Thomas, H. Haggag, K. Egan, A. Bergemont, P. Jansen, "Precision Electrical Trimming of very Low TCR Poly-SiGe Resistors", IEEE Electron. Dev. Letters, vol. 21 (2000), 6, pp.283-285	<input type="checkbox"/>

If you wish to add additional non-patent literature document citation information please click the Add button

EXAMINER SIGNATURE

Examiner Signature		Date Considered	
--------------------	--	-----------------	--

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.